

Erratum

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Potato virus Y -resistant mutation induced by the combination treatment of ion beam exposure and anther culture in *Nicotiana tabacum* L.

Plant Biotechnology **16**(4):285 - 289(1999).

Fig. 3 at page 288 was printed upside - down by the mistake of the publisher after galley proof reading. It should be corrected as below:

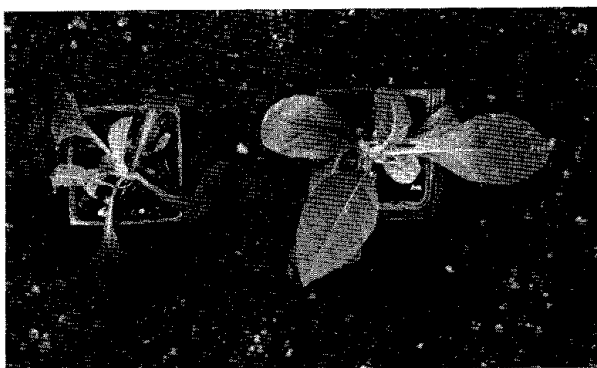


Fig. 3 Haploid plant resistant (right) and susceptible (left) to potato virus Y race T, 21 days after inoculation. Severe symptoms such as veinal necrosis, mottling puckered leaves and stunting were observed in susceptible plant.